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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
AA						
AB						
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FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Abstract	
						Yes	No
AM	2001-23967	01/26/2001	JP	H01L	21/3065	X	
AN	2001-267299	09/28/2001	JP	H01L	21/3065	X	
AO							
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AT							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

1763	AU	M.A. Lieberman, Translated by H. Sato, "Principles of Plasma Discharges and Materials Processing", Published November 20, 2001 by ED Research Co., Page 116
	AV	
	AW	
	AX	
	AY	
	AZ	
Examiner <i>Prof. Zeng</i>		Date Considered 10/2/06